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GEMOLOGICAL
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LABORATORY GROWN DIAMOND REPORT

December 20, 2025

IGI Report Number **LG758580879**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **8.39 X 5.99 X 4.05 MM**

GRADING RESULTS

Carat Weight **2.04 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG758580879**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG758580879
Report verification at igi.org

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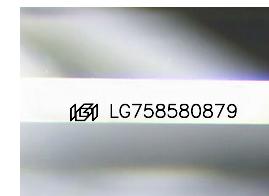
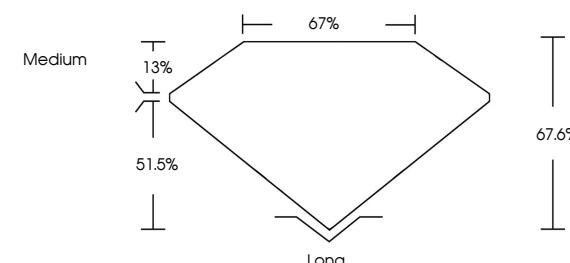
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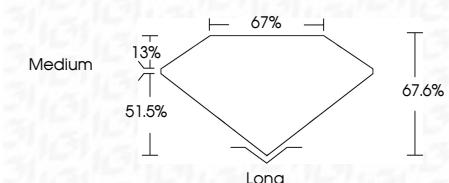
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PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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EMERALD CUT

8.39 X 5.99 X 4.05 MM

2.04 CARATS

E

VS 1

67.6%

67.6%

Medium

Long

EXCELLENT

EXCELLENT

NONE

IGI

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